



Docket No.: H6808.0004/P004
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Atsushi Takane, et al.

Examiner: Phillip A. Johnston

Application No.: 10/082,286

Art Unit: 2881

Filed: February 26, 2002

For: SEMICONDUCTOR INSPECTION SYSTEM

AMENDMENT

Commissioner for Patents
MS: Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the non-final Office Action dated April 20, 2005.
Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins
on page 2 of this paper.

Remarks begin on page 10 of this paper.